

13281 U.S. PTO
07/22/03

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PATENT TRADEMARK OFFICE

July 22, 2003

Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: New U.S. Patent Appln.
Our Ref: 010986.52582US

Sir:

Transmitted herewith for filing is a Continuation-In-Part Application of pending PCT Application No. PCT/JP02/00429 filed on January 22, 2002 of:

Yoshihiro KATO, Tadashi GOTO, Hikaru YOSHITAKA and Makoto AOKI

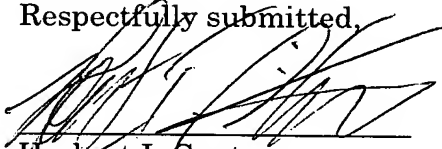
entitled: **PLASMA PROCESS SYSTEM AND PLASMA PROCESS METHOD**

Enclosed are:

1. Specification, including 19 claims (pages 1-34).
2. 13 Sheets of formal drawings showing Figs. 1-13, 14a-14d, and 15-19.
3. Application Data Sheet.
4. Priority is being claimed under 35 U.S.C. §119 and 37 C.F.R. §1.55 based on Priority Document Nos. 2001-13570, filed in Japan on January 22, 2001 and 2001-14011, filed in Japan on January 23, 2001.
5. Benefit is hereby claimed under 35 U.S.C. §120 of pending PCT Application No. PCT/JP02/00429 filed on January 22, 2002.
6. Information Disclosure Statement, including International Search Report and PTO-1449 Form w/1 reference.

The filing fee is being deferred at this time.

Respectfully submitted,


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